

Dimensional Metrology Course - 2003

	Monday 17-Nov	Tuesday 18-Nov	Wednesday 19-Nov
	All lectures presented in english.		
8:00	Registration and Coffee	Coffee	Coffee
8:30	Dim Met Basics (JP)	Gauge Blocks (JD)	Image Metrology (JP)
9:00			
9:30			
10:00			
10:30	Coffee	Coffee	Coffee
11:00	Dim Met Basics (JP)	Uncertainty WS: Micrometer Calibration Example (JD)	Temperature for Dimensional Metrology (JD)
11:30			
12:00			
12:30	Lunch	Lunch	Lunch
13:00			
13:30	Uncertainty in Dimensional Metrology (JD)	Diameter and Roundness (KD)	CMM Basics (KD)
14:00			
14:30		Surface Profile & Roughness (KD)	
15:00			
15:30	Coffee	Coffee	Coffee
16:00	Laser Interferometry (JP)	Correlation Can Reduce Uncertainty (KD)	Angle (JP)
16:30			
17:00			
17:30			